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PATENT

1775

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Robert J. Falster et al.

Art Unit 1775

Serial No. 10/073,506

Filed February 11, 2002

Confirmation No. 6190

For EPITAXIAL SILICON WAFERS WITH NITROGEN STABILIZED OXYGEN  
PRECIPITATION NULEI AND PROCESS FOR MAKING SAME

March 12, 2002

Office of Initial Patent Examination's  
Customer Service Center  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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SUPPLEMENTAL APPLICATION DATA SHEET

SIR:

Applicants incorrectly listed the first named inventor twice on the Application Data Sheet filed on February 11, 2002 respecting the above-referenced application. In accordance with 37 CFR 1.76(d)(3) & (4), Applicants respectfully submit herewith a Supplemental Application Data Sheet. Applicants also respectfully request a corrected filing receipt reflecting this correction.

Respectfully submitted,

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\*Enclosure